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APPLICATION NO.	F.	ILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/757,521	·	01/15/2004	Woong-Kwon Kim	3430-0200P 4585 EXAMINER	
2292	7590	11/15/2004			
BIRCH ST	EWART	KOLASCH & B	NGUYEN	NGUYEN, HOAN C	
PO BOX 747 FALLS CHURCH, VA 22040-0747				ART UNIT PAPER N	
111000 011				2871	<u> </u>

DATE MAILED: 11/15/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)						
Office Action Summary	10/757,521	KIM, WOONG-KWON						
Office Action Summary	Examiner	Art Unit	ار مو					
	HOAN C. NGUYEN	2871	18"					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply								
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).								
Status								
1) Responsive to communication(s) filed on	_•							
2a) This action is FINAL . 2b) ☑ This	action is non-final.							
3) Since this application is in condition for allowar	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is							
closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 45	53 O.G. 213.						
Disposition of Claims								
4) Claim(s) <u>1-4</u> is/are pending in the application.								
4a) Of the above claim(s) is/are withdraw	vn from consideration.	•						
5) Claim(s) is/are allowed.								
6)⊠ Claim(s) <u>1-4</u> is/are rejected.								
7) Claim(s) is/are objected to.								
8) Claim(s) are subject to restriction and/or	election requirement.							
Application Papers								
9) The specification is objected to by the Examine	·.							
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.								
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).								
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).								
11) The oath or declaration is objected to by the Ex	aminer. Note the attached Office	Action or form P	ΓΟ-152.					
Priority under 35 U.S.C. § 119								
12) Acknowledgment is made of a claim for foreign	priority under 35 U.S.C. § 119(a))-(d) or (f).						
a) All b) Some * c) None of:	s have been received							
 Certified copies of the priority documents have been received. Certified copies of the priority documents have been received in Application No 								
3. Copies of the certified copies of the priority documents have been received in this National Stage								
application from the International Bureau (PCT Rule 17.2(a)).								
* See the attached detailed Office action for a list of the certified copies not received.								
Attachment(s)								
1) X Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	4) Interview Summary Paper No(s)/Mail Da							
3) X Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)	5) 🔲 Notice of Informal P		O-152)					
Paper No(s)/Mail Date <u>01/1</u> 5/04	6) Other:							

Art Unit: 2871

DETAILED ACTION

Double Patenting

The nonstatutory double patenting rejection is based on a judicially created doctrine grounded in public policy (a policy reflected in the statute) so as to prevent the unjustified or improper timewise extension of the "right to exclude" granted by a patent and to prevent possible harassment by multiple assignees. See *In re Goodman*, 11 F.3d 1046, 29 USPQ2d 2010 (Fed. Cir. 1993); *In re Longi*, 759 F.2d 887, 225 USPQ 645 (Fed. Cir. 1985); *In re Van Ornum*, 686 F.2d 937, 214 USPQ 761 (CCPA 1982); *In re Vogel*, 422 F.2d 438, 164 USPQ 619 (CCPA 1970);and, *In re Thorington*, 418 F.2d 528, 163 USPQ 644 (CCPA 1969).

A timely filed terminal disclaimer in compliance with 37 CFR 1.321(c) may be used to overcome an actual or provisional rejection based on a nonstatutory double patenting ground provided the conflicting application or patent is shown to be commonly owned with this application. See 37 CFR 1.130(b).

Effective January 1, 1994, a registered attorney or agent of record may sign a terminal disclaimer. A terminal disclaimer signed by the assignee must fully comply with 37 CFR 3.73(b).

Claims 1 and 3 are rejected under the judicially created doctrine of obviousness-type double patenting as being unpatentable over claims 1 and 6 of U.S. Patent No. 6,717,638. Although the conflicting claims are not identical, they are not patentably distinct from each other because a semiconductor layer in U.S. Patent No. 6,717,638 of claim 1 and 6 with a source electrode and a drain electrode forms TFT of claims 1 and 3 in the instant application.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

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1. Claims 1-4 are rejected under 35 U.S.C. 102(b) as being anticipated by Midorikawa et al. (US6281955B1).

In regard to claims 1 and 3, Midorikawa et al. teach (Fig. 1) a LCD device comprising:

- a thin film transistor TFT 14 formed on a substrate 11, the TFT having a gate 16,
 a source 20 and a drain 18;
- a color filter layer 24a-c formed on the TFT to be in direct contact with at least the source or drain;
- a pixel electrode 30 formed above the color filter layer to be in electrical contact with the drain;

wherein the color filter layer and at least source or the drain in direct contact such that are no intermediaries therebetween (claim 2) or no passivation layer formed between TFT and the color filter layer (claim 4).

Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure:

Kashiwazaki et al. (US 6162510 A) disclose a method for manufacturing a color filter comprising a step for charging ink comprising a thermosetting resin composition onto an opening of a black matrix provided on a transparent substrate and a step for curing the ink by heat treatment.

Sato (US 6111623 A) discloses an active matrix substrate with a color filter having colored layers of red, green, and blue is formed on the transparent electrodes.

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Zhong et al. (US 5994721 A) disclose a high aperture active matrix liquid crystal display (AMLCD) with the color filters formed on the active substrate in a manner such that the filters also overlap the address lines and function as an insulating layer between the pixel electrodes and address lines in the areas of overlap.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to HOAN C. NGUYEN whose telephone number is (571) 272-2296. The examiner can normally be reached on MONDAY-THURSDAY:8:00AM-4:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Kim H Robert can be reached on (571) 272-2293. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

> HOAN C. NGUYEN Examiner Art Unit 2871

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PRIMARY EXAMINER